

Docket No.: 50432-601



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Minh Van NGO, et al.

Confirmation Number: 3500

Application No.: 10/617,451

0/617,451

Group Art Unit: 2812

Filed: July 11, 2003

Examiner: Lindsay Jr, Walter Lee

For: PECVD SILICON-RICH OXIDE LAYER FOR REDUCED UV CHARGING:

AMENDMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated September 22, 2004.